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SEP 28 2006

Docket No. 740756-2718

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Mitsuhiro ICHIJO et al.) Group Art Unit: 2814
Application No. 10/804,053) Examiner: Long Pham
Filed: March 19, 2004) Confirmation No. 7738
For FILM FORMATION METHOD AND) Dated: September 28, 2006
MANUFACTURING METHOD OF
SEMICONDUCTOR

REQUEST FOR RECONSIDERATION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 28, 2006, please consider the remarks in connection with the above-identified application as follows:

I hereby certify that this correspondence is being
facsimile transmitted to the USPTO at 571-273-8300
on 9-28-2006
Michelle Duvall
Michelle Duvall

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